

35.C10499 CONT. I/DIV. I



PATENT APPLICATION

21/EXT
F

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

T. Steptoe
1/26/01

In re Application of:)
HIDEAKI MITSUTAKE, ET AL.)
Application No.: 09/045,681 ✓)
Filed: March 23, 1998)
For: ELECTRON BEAM APPARATUS) January 17, 2001
AND IMAGE FORMING)
APPARATUS)

Examiner: M. Gerike

Group Art Unit: 2879

Commissioner for Patents
Washington, D.C. 20231

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JAN 24 2001
TECHNOLOGY CENTER 2800

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition to extend the time for response to the Office Action dated July 17, 2000, for three months from October 17, 2000 to January 17, 2001. A check in the amount of \$890.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

The Examiner is respectfully requested to amend the above-identified application as follows:

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890.00 OP

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